

TURN YOUR SEM INTO A 3D MEASUREMENT DEVICE







3D SURFACE METROLOGY WITH THE SEM

MeX turns any SEM into a measurement device

MeX is a stand alone software package that turns any SEM with digital imaging into a true surface metrology device. Using stereoscopic images the software automatically retrieves 3D information and presents a highly accurate, robust and dense 3D dataset which is then used to perform traceable metrology examination. The results are obtained irrespective of the SEM magnification providing metrology at macro and micro levels.

The software is self installing and is extremely easy to use. The modular design of the package allows flexibility in use; it also permits users, with a single repetitive task to perform, to purchase modules according to requirements. The analysis modules allow measurement of profile, roughness, area, volume and "Z" height. All measurements are traceable, can be calibrated and conform to ISO standards.

The performance of MeX has been proved by many customers in leading companies and universities throughout the world providing imaging and analysis previously unobtainable with SEM images.





UNIQUE FEATURES ALLOW NEW APPLICATIONS

Robust and highly accurate at any magnification

The core of MeX is formed by its innovative 3D reconstruction algorithms. The research and development team of Alicona Imaging have invented methods that generate highly accurate, dense and robust results. This unique performance becomes obvious in images of complex structures with steep edges and drop offs in addition to demanding samples with low texture and signal-to-noise-ratio. This high quality is achieved irrespective of image magnification.



Automatic calibration allows traceable 3D measurement

Conventional approaches rely on the use of two images. This comes with the major drawback that the overall accuracy of the 3D measurement is partly dependent on the accurate reading of the tilt angle. It is also commonly known that this reading maybe

error-prone and can only be achieved to a certain level of accuracy. Latest developments of Alicona have extended this stereoscopic approach to a third image. As a result the user defined parameters, such as the tilt angle, are automatically calculated. This omits the influence of the user and allows, for the first time, traceable 3D measurement in the SEM.

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Optical Measurement and Inspection

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Easy to use, easy to install

No additional hardware is necessary to run MeX. As a pure software solution MeX can be operated with any SEM requiring only images in common formats. The software is self-installing and works com-

pletely independently of any third party drivers or components. The user interface of the overall package is very user friendly and self-explanatory. Data is obtained quickly and effectively. A wizard guides the user through the reconstruction process which then automatically converts the information to a 3D

data set. The consecutive analysis is again intuitive and the user is not confronted with unnecessary functionality. The user finds exactly what is expected from a 3D metrology package.

Comprehensive depth analysis

The uniqueness of MeX is in its accuracy and robustness. But in order to perform appropriate measurements, beyond conventional visualization, analysis following international standards must be available. In MeX, the easy to

use, roughness and area analysis are provided to EN/ISO standards. Measurements are performed directly on the SEM image. Printing and exporting the actual representations of an image are a one-click operation. The visual link between the surface and the image enable precise and flexible measurements. Even volumetric analysis is conveniently feasible. Therefore MeX is the only software package that turns a SEM into a true 3D metrology device.



THE TECHNICAL PRINCIPLE OF MEX

3D measurement based on stereo images

The image formation process in the SEM is based on perspective projection. Similar to a conventional light microscope the three dimensional object is projected onto a two dimensional image plane and information about the third dimension is lost. Note, the large depth of focus in SEM provides full depth of focus images, but does not allow to measure depth. Only two dimensional measurements in the image plane are feasible.

An eucentric tilting of the stage, meaning that the intersection of the primary electron beam with the specimen define the centre of tilting, yield a second image of the specimen observed form a different viewpoint. A so called stereoscopic image is generated. Overlay techniques such as red-green coloring provide anaglyph viewing and thus depth perception but again no quantitative analysis. The leading technology of Alicona now automatically identifies points in each of the images that belong to the same point on the specimen. From theses so called homologous points the true three dimensional coordinates of the observed point can be recovered. This demanding task is robustly solved for each pixel in each of the images and thus a dense 3D model of the specimen is obtained. An additional third image captured from a third tilt position allows to automatically refine given calibration data. Thus traceable results are obtained.



AUTOMATIC CALIBRATION

Verification of measurements through height step



Height measurements with the AutoCalibration can be verified using a micro-contour-artefact that is calibrated by the PTB (Physikalisch Technische Bundesanstalt, Braunschweig). The depth measurement standard from the PTB contains grooves of different depth (from 240nm to 50μ m).

- The unique AutoCalibration works fully automatically. Alicona is the only supplier able to offer this technology.
- MeX is the only real metrology package that allows numerically accurate measurements independent on the magnification.
- MeX allows extended analysis features such as ISO conform roughness analysis and extended form analysis.

Micro- contour-artefact, calibrated by PTB

RECONSTRUCTIONS AND ANALYSIS IN THE SEM



PTB		Stereo Creator	AutoCalib
24.04µm ±0.07µm		25.3µm	24.10µm
	Me	asurement resul	ts in comparison
	Stereo Creator	-9,5°	9,5°
	AutoCalib	-10,05°	10,00°

Input image, 3D reconstruction and height measurement with the AutoCalibrator. The AutoCalibrator refines the calibration data and allows more accurate measurements.

Angle refinement with AutoCalibration

Verification of measurements through radius measurement



Measurements of the pure software solution MeX can be verified using a micro-contour-artefact that is calibrated by the PTB (Physikalisch Technische Bundesanstalt, Braunschweig). The artefact contains different regions including steep flanks, height steps and cylindrical elements. The following measurements can be verified:

- Circle measurements
- Steep flanks
- · Depth measurements

PTB calibrated micro artefact with steep flanks, height steps and cylindrical elements.

RECONSTRUCTIONS AND ANALYSIS IN THE SEM

PTB	Stereo Creator	AutoCalib
80µm ± 2µm	75.11µm	81.14µm

Comparison of circle measurements

Stereo Creator	-10°	10°
AutoCalib	-10,86°	11.01°

Verification of circle measurements. One of the input images (SEM) obtained from the region with the cylindrical valleys. The radius of the circle was measured with MeX – AutoCalibration.

Angle refinement with AutoCalibration



COMPREHENSIVE ANALYSIS CAPABILITIES FOR SURFACE MEASUREMENT AND CHARACTERIZATION

Height & Roughness Analysis

Profile measurement enables virtual cutting of specimen. The user defines a path on the optical image and receives the corresponding 3D profile. Roughness and contour measurements conform to recognized EN ISO 4287/4288 international standards. The profile analysis also allows the fitting of primitives such as circles, angles or others. Further, manual and semi automatic measurement possibilities are provided.

- Profile extraction with different width
- Filtering of the profile with selectable Lc value with ISO 4288 conformity information
- · Manual cursor measurement
- Automatic measurements of lines, parallel lines, single height steps, double height steps, ISO 5436 conform height steps, angles, 2 line angles and circles
- ISO 4287 conform calculation of the following primary parameters: Pa, Pq, Pz, Pp, Pv, Pc, PSm, Psk, Pku, Pdk
- ISO 4287 and ISO 11562 conform calculation of the following roughness parameters: Ra, Rq, Rz, Rp, Rv, Rc, RSm, Rsk, Rku, Rdk
- ISO 4287 conform calculation of the following waviness parameters: Wa, Wq, Wz, Wp, Wv, Wc, WSm, Wsk, Wku, Wdk
- · Calculation of fourier spectrum of profiles
- · Calculation of bearing ratio curve
- · Calculation of statistical parameters of profiles

Area Analysis

Area analysis provides the determination of Ra, Rq and Rz. Parameters like roughness, waviness and the fractal dimension of user defined surface patches are achieved. The user defines a region of interest such as a rectangle or polygon and MeX automatically calculates the values. For the visual representation of the surface a grey scale or pseudo colored depth map can be used. It is also possible to display ISO-lines to highlight depth variations.

- Calculation of surface parameters like Sa, Sq, Sz, Sp, Sv
- Calculation of fractal dimension
- · Extraction of horizontal and vertical profiles
- Filtering of profiles
- Calculation of mean of the primary, roughness and waviness values of the horizontal and vertical profile
- Calculation of the primary, roughness and waviness
 parameter of the mean horizontal and vertical profile
- Calculation of bearing ratio curve
- Calculation of bearing area curve

Volume Analysis

Volume analysis calculates the volume of voids and protrusions. The measurement area is defined directly on the optical image. The volume is determined throughout the computation of a soap film model. For the 3Dboundary of the selected area MeX calculates a covering surface that behaves like a soap film.

- · Selectable area for volume measurement
- Selectable reference surface (plane, minimum spanning surface, top and bottom cover)
- Automatic calculation of reference plane from 3D points

2D Image Analysis

2D image analysis allows the performance of manual and semi automatic measurement of simple primitives. Also, the ability to write on the images as well as saving measurement results in a comprehensive and easy to use database is provided.

- Manual measurement of lines, parallel lines, arcs, circles, ellipses, polygons, polylines, freehand, marker
- · Automatic measurement of lines, parallel lines, circles, arcs
- Statistical calculation of results such as mean, standard deviation, minimum, maximum, median
- · Automatic search of equally shaped structures on the image



PRACTICAL SOLUTIONS WITH MEX









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CANCER RESEARCH IN LIFE SCIENCE

Courtesy R. Anderson, University of Illinois, Chicago/USA

Quantitative surface analysis with the SEM is often used to investigate damage evolution in materials in addition to assisting in the design of more fracture resistant materials. The optimization of materials is complicated by the fact that the material properties may need to vary locally within the component. An example of this is cutting tools that need to be very hard at the cutting edge but be tough in the interior of the material. MeX is used to study deformation and fracture behaviour to optimize the performance of inhomogeneous materials. Dense, robust and accurate 3D reconstructions are created to allow measurement of fracture surface profiles, roughness parameters and fractal dimensions.

3D measurement results computed by MeX lead to significant understanding of parameters such as fracture toughness, crack growth and propagation or fracture resistance.

Modern high-tech steel is one of today's most important materials in all kinds of industries, transportation or medicine. The surface characteristics can relate to appearance, conductivity, corrosion resistance, wear or many other properties. MeX is an essential tool to assist with surface characterization for quality assurance and failure analysis. The 3D measurement capabilities provide robust and accurate results on properties such as fracture and compression strength, notch bar impact value or creep strength.

MeX is also used to evaluate faults in steel production. The overall quality of steel is dependent on the topography of the roller used in its production. As soon as the roller exhibits any kind of surface defects the surface of the steel will show dimples and inclusions. Using the measurement capabilities of MeX these faults can be analysed and the source of the defect traced.

Every gun leaves distinctive marks and traces on the bullet cartridge and projectile, similar to fingerprints. These traces on a gun, found at a crime scene, can be instrumental to prove guilt of suspects. Conventional methods are based on the analysis of 2D images to identify which bullet has been fired from which weapon. However, the 3D visualization and measurement of the firing pin and cartridge indentation is far more precise. It is here that MeX offers unique capabilities providing a highly accurate, dense and robust 3D reconstruction with full depth of focus taken over a large field of view. Using MeX a user can, for example, measure the volume of a firing pin impression along with profile that can be related directly to the firing pin. This leads to a numerical evaluation independent from any subjective point of view, providing rapid and understandable analytical data for interpretation.

MeX can be used for the measurement of diameters, depths, angles of slope and volumes of craters created by impact of mineral grains on metals. This is part of the calibration work that has been done to help interpret cometary dust impacts on the stardust spacecraft, which returned to earth recently, carrying the first comet samples ever collected.

MeX has been used as a measurement tool to interpret the size, density and composition of particles responsible for making micrometre-scale craters. The ease of use of MeX, with its intuitive graphical interface, has enabled the quick and simple measurement of the required parameters. Data input and the range of easily interpreted reconstructions make MeX to a most suitable tool for quantified reconstruction of crater shapes from tilted stereo-pair electron micrographs.

MeX turns any SEM, in biological and non biological applications, into a full 3D measurement device.

Until MeX, the biological user has had limited methods that could provide accurate and robust measurements of surface texture, volumes and area of bulky irregular samples. In recent research MeX has been used to characterise the topography of the extracelluar matrix (ECM) underlying colon cancer cells at various stages. Also, the enhanced visualization and roughness measurement capabilities of MeX has provided additional information, not previously available, about the cancers' behaviour. These findings have implications not only for improving the general understanding how colon cancer and metastasizes grow, but, also lead to a better understanding of the role of the ECM topography in cancer.





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